

CP2811

PATENT
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#6/ Assoc
P/A
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v

In re Application of:

Pan et al.

Serial No.: 09/073,494

Filed: May 6, 1998

For: TECHNIQUE FOR ELIMINATION
OF PITTING ON SILICON SUBSTRATE
DURING GATE STACK ETCH

Examiner: To be assigned

Group Art Unit: 2811

Attorney Docket No.: 2915.1US
(96-149.1)



CERTIFICATE OF MAILING

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(37 C.F.R. § 1.34(b))

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Sir:

In accordance with 37 C.F.R. § 1.34(b), please recognize the following individual as an associate agent/attorney herein in connection with the above-identified patent application:

Devin R. Jensen, Reg. No. P-44,805

Respectfully submitted,

Joseph A. Walkowski

Joseph A. Walkowski
Reg. No. 28,765
Attorneys for Applicants
TRASK, BRITT & ROSSA
P.O. Box 2550
Salt Lake City, Utah 84110
Telephone: (801) 532-1922

Date: September 21, 1999

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